

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Kazuo TESHIROGI et al.**

Serial Number: **Not Yet Assigned**

Filed: **November 24, 2003**

**Customer No.: 38834**

For: **FILM LAMINATION APPARATUS AND METHOD AND A MANUFACTURING  
METHOD OF A SEMICONDUCTOR APPARATUS**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

November 24, 2003

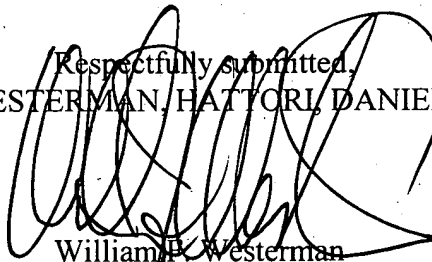
Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge  
Deposit Account No. 50-2866.

Respectfully submitted,  
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



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Enclosures: PTO-1449; References (2)

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Atty. Docket No. 032131	Serial No. New Appln.
	Applicant(s): Kazuo TESHIROGI et al.	
	Filing Date: November 24, 2003	Group Art Unit:

### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

### FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AE 7-25463	03/22/95	Japan	Abstract. Cited in the specification
_____ AF 2002-76096	03/15/02	Japan	Abstract. Cited in the specification
_____ AG			
_____ AH			
_____ AI			
_____ AJ			
_____ AK			

### OTHER DOCUMENTS

_____	AL	
_____	AM	
_____	AN	

Examiner	Date Considered
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